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2080-3-191Application Number
10/729,558**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION****Applicant**Woo Seong Yoon, Jea Yong Yoo, Tae Ho Kim and
Byung Jin Kim

(Use several sheets if necessary)

Filing Date
December 4, 2003**Group Art Unit**
2155**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLA SS	FILING DATE IF APPROPRIATE
	US 2003/0028892 A1	02/06/2003	Greg Gewickey, et al.	H04N	7/173	
	US 2003/0161615 A1	08/28/2003	Yasufumi Tsumagari, et al.	H04N	5/781	
	5,929,857	07/27/1999	Dinallo, et al.	G06F	003/14	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
	11-098467	04/09/1999	JAPAN	H04N	5/93	YES (Abstract)
	10-136314	05/22/1998	JAPAN	H04N	5/93	YES (Abstract)

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**EXAMINER**

/Krisna Lim/

DATE CONSIDERED 05/30/2009

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.